

S/N 10/081,818

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jerome M. Eldridge et al.

Examiner: Tu-Tu Ho

Serial No.: 10/081,818

Group Art Unit: 2818

Filed: February 20, 2002

Docket No.: 1303.045US1

Customer No.: 73115

Confirmation No.: 3148

Title: ATOMIC LAYER DEPOSITION OF METAL OXIDE AND/OR LOW
ASYMMETRICAL TUNNEL BARRIER INTERPLOY INSULATORS

COMMUNICATION RE: FEE ADDRESS

Mail Stop Issue Fee
Commissioner for Patents
P.O.Box 1450
Alexandria, VA 22313-1450

In response to the Notice of Allowance and Issue Fee Due, please record the Fee Address
under the provisions of 37 CFR 1.363 as the following:

Customer Number 26809

which is associated with Micron Technology, Inc..

Please direct any inquiries to the undersigned attorney at (612) 349-9587.

Respectfully submitted,

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Date 6 Nov. '08
TBC:CMG:ker

By 
Timothy B. Clise
Reg. No. 40,957

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 7 day of November, 2008.

KATHLEEN F. ROTHROCK
Name

Abbiee E. Roach
Signature